



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masateru YAMAMOTO et al.

ATTN: Application Branch

Application No.: 10/625,687

Docket No.: 116661

Filed: July 24, 2003

For: SURFACE EMITTING SEMICONDUCTOR LASER AND METHOD OF
FABRICATING THE SAME

FILING RECEIPT STATUS REQUEST

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

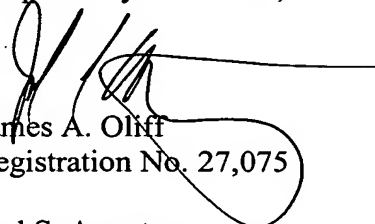
Sir:

The above-captioned patent application was filed on July 24, 2003. A copy of the postcard receipt is attached hereto.

The original Filing Receipt has not yet been received. It is respectfully requested that the original Filing Receipt be immediately forwarded to the attorneys of record at the address set forth below.

If there are any questions regarding this matter, please contact the undersigned at the telephone number set forth below.

Respectfully submitted,



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Date: March 24, 2004

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PTO RECEIPT FOR FILING OF PAP



► Mail Room (Regular Delivery)

The following papers have been filed:

App trans; CK 144546 (\$1116); 36 pp spec/31 clms/abstract; 7 pp dwngs (1-4); Dec; Assign trans; CK 144547 (\$40); Assign; IDS; Pto 1449 w/1 Ref w/abstract & transl.

Name of Applicant: Masateru YAMAMOTO, Jun SAKURAI

Serial No.: New U.S. Application

Atty. File No.: 116661

Title (New Cases): SURFACE EMITTING SEMICONDUCTOR LASER AND METHOD OF FABRICATING THE SAME

Sender's Initials: JAO/mlo

ASSIGNEE: FUTTEROX CO., LTD.